

Please type sign (+) inside this box →



PTO/SB/21 (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paper Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

<h1>TRANSMITTAL FORM</h1> <p>(to be used for all correspondence after initial filing)</p>	Applicati n Num b r	09/625,336
	Filing Date	Jul 25, 2000
	First Named Inventor	Kori, Moris
	Group Art Unit	1763
	Examiner Name	Unassigned
Total Number of Pages in This Submission		Attorney Docket Number 4714d1/AMI-07

RECEIVED
JAN 18 2002
TC 1700

ENCLOSURES (check all that apply)		
<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment / Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/ Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s)	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): 1. Form 1449 with 3 references 2. Return Receipt Postcard to Kenneth C. Brooks 3. Return Receipt Postcard to Applied Materials, Inc.
Remarks		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual name	Law Office of Kenneth C. Brooks
Signature	
Date	November 8, 2001

CERTIFICATE OF MAILING			
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on this date: _____			
Type or printed name	Jennifer Bonham		
Signature		Date	November 8, 2001

Burden Hour Statement: This form is estimated to take 0.2 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kori et al.

Serial No: 09/625,336

Filed: July 25, 2000

For: METHOD AND SYSTEM FOR CONTROLLING THE PRESENCE OF
FLUORINE IN REFRACTORY METAL LAYERS

PATENT APPLICATION

Group Art Unit: 1763

Examiner: unassigned

Supplemental Information Disclosure Statement

Hon. Commissioner
for Patents
Washington, D.C. 20231

RECEIVED
JAN 18 2002
TC 1700

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. A copy of each reference recited below accompanies this document. Also enclosed are two (2) sheets of PTO form 1449 listing these references.

PATENT DOCUMENT

Patent Number

5,580,380

Inventor

Liu et al.

Grant Date

03-Dec-96

PCT DOCUMENT

Publication No.

WO 98/51838

Inventor

Rajagopalan et al.

Publication Date

19-Nov-98



NON-PATENT DOCUMENT

Kitagawa et al. Hydrogen-Mediated Low-Temperature Epitaxy of Si in Plasma-Enhanced Chemical Vapor Deposition, Applied Surface Science, pp. 30-4 (2000).

RECEIVED
JAN 18 2002
TC 1700

CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to :
BOX Patent Application, Commissioner
for Patents, Washington D.C. 20231

Signed: Jennifer Bonham

Typed Name: Jennifer Bonham

Date: 11.8.01

Respectfully submitted,

Kenneth C. Brooks
Reg. No. 38,393